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(71)Applicant : RICOH CO LTD

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(72)Inventor : SHIMIZU TOMOHITO

YAMAMOTO KAZUTADA

ISHIURA SUKEAKI

ONODA SHIGEO

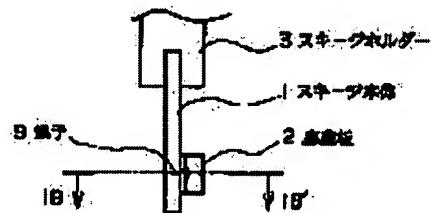
ITO YOSHIHIKO

(54) METHOD AND APPARATUS FOR COATING SQUEEGEE, SCREEN

(57)Abstract:

PROBLEM TO BE SOLVED: To reduce an unevenness of a film thickness after coating with an ink by mounting a plurality of baffle plates perpendicularly at a squeegee surface in a widthwise direction of a squeegee body, thereby making an ink liquid amount held in the width direction of the squeegee uniform.

SOLUTION: A plurality of baffle plates 2 are installed perpendicularly at a squeegee surface at a certain interval in a width direction of a squeegee body 1 by a screw 9 or the other fastening means. The plates 2 are preferably aligned at an installing interval of 10 to 50 mm in the width direction of the body 1. And, a thickness of each of the plates 2 is preferably 0.3 to 2 mm. And, a length of the plate 2 of the squeegee in a perpendicular direction to the body 1 is 10 to 50 mm, and a length of the plate 2 in a parallel direction with the body 1 is 10 to 50 mm. And, a position of a lower end side of the plate 2 is raised 1 to 5 mm from an end of the body 1.



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